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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Thomas Jung
Patent No. : 6,841,202 B1
Issue Date : January 11, 2005
Appl. No. : 09/743,545
Filed : July 28, 1999
Title : DEVICE AND METHOD FOR THE VACUUM PLASMA
PROCESSING OF OBJECTS
Docket No. : 65,243-001

"MAKE OF RECORD" LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

The following error has been found in the above-identified United States Letters Patent:


IN THE DRAWING:

Figure 1 should be corrected to show --6'-- , instead of [[6]] as duly noted in the specification and as originally portrayed in the drawings upon the original filing of this application.

It is respectfully submitted that the foregoing typographical error be made of record in the file of the subject patent.

Respectfully submitted

HOWARD & HOWARD ATTORNEYS, P.C.

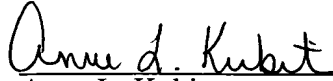

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March 22, 2005
Date

CERTIFICATE OF MAILING

I hereby certify that the attached "**Make of Record**" Letter is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on this **March 22, 2005**.



Anne L. Kubit